



TOSHIKAZU ONISHI ET AL.

Application No.: 10/014,131

Filed: December 13, 2001

For: METHOD FOR MANUFACTURING ELECTRON EMISSION ELEMENT, ELECTRON SOURCE,

AND IMAGE FORMING APPARATUS

Examiner: K. Ramsey

Group Art Unit: 2879

Date: February 26, 2004

THE COMMISSIONER FOR PATENTS P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

| X | No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED							
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE	
TOTAL CLAIMS	* 10	MINUS	** 20	0	x \$9 \$18	0	
INDEP. CLAIMS	* 6	MINUS	*** 6	0	x \$43 \$86	0	
Fee for Mu	0						
	0						

If the entry in Column 2 is less than the entry in Column 4, write "0" in Column 5. If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.

If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space.

	Verified Statement claiming small entity status is enclosed, if not filed previously.				
	A check in the amount of \$ is enclosed.				
	Charge \$ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed				
X	Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06 1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.				
	A check in the amount of \$ to cover the fee for a month extension is enclosed.				
	A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.				
X	Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.				
	Respectfully submitted,				
	Attorney for Applicants Registration No. 4240 6				

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza New York, New York 10112-3800 Facsimile: (212) 218-2200

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re	Application of:)	
		:	Examiner: K. Ramsey
TOSE	HIKAZU ONISHI ET AL.)	
		:	Group Art Unit: 2879
Appli	cation No.: 10/014,131)	
		:	
Filed:	December 13, 2001)	
		:	
For:	METHOD FOR MANUFACTURING)	
	ELECTRON EMISSION ELEMENT,	:	
	ELECTRON SOURCE, AND IMAGE)	
	FORMING APPARATUS	:	February 26, 2004

Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450

SECOND PRELIMINARY AMENDMENT

Sir:

Preliminary to continued examination, and after entry of the Preliminary

Amendment filed on December 1, 2003, please further amend the above-identified application as follows, the claims changes being reflected in the listing that begins at page 2, and the Remarks beginning at page 7.